## **PATENT**

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

IN RE APPLICATION OF:

JEFFREY L. MACKEY ET AL.

**APPLICATION NO.:** 

10/684,794

FILED:

For:

**OCTOBER 14, 2003** 

METHODS AND SYSTEMS FOR

CONTROLLING RADIATION BEAM

**CHARACTERISTICS FOR** 

MICROLITHOGRAPHIC PROCESSING

IARK OFFICE

EXAMINER:

**HUNG NGUYEN** 

ART UNIT:

2851

CONFIRMATION NO.:

4238

## **Comments on Statement of Reasons for Allowance**

Mail Stop Issue Fee Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

In the Notice of Allowability mailed January 14, 2005, the Examiner allowed claims 2-15, 17-29, 31-40 and 42-49. Although the applicants' attorney agrees with the Examiner's conclusion that these claims are allowable, the applicants' attorney notes that the claims may be allowable for reasons other than those identified by the Examiner in the Office Action dated September 21, 2004, and does not concede that the Examiner's characterizations of the terms of the claims and the prior art are correct.

Respectfully submitted, Perkins Coie LLP

Date: 3/31/05

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